Impurities distribution and recombination activity in as-grown and annealed multicrystalline silicon

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Abstract
To study the impact of annealing on the impurities distribution and the recombination activity of multicrystalline silicon, the synchrotron-based x-ray analysis, the electron beam induced current, and the photoluminescence mapping of near band edge and 0.78 eV deep emission were performed before and after annealing. Nickel agglomerates existed along random grain boundaries; while not along most of coincidence site lattice grain boundaries (Σ3, Σ 9 and Σ 27a) and some of random grain boundaries. At most of the recombination active grain boundaries, the existence of nickel agglomerates was indicated.

1. Introduction
Multicrystalline silicon grown by cast method has been playing an important role in PV market for the decade due to the well balanced cost and efficiency. Today, further cost reduction is expected by using less pure silicon feedstock, that is, solar grade silicon [1-6]. Solar grade silicon cannot avoid incorporation of relatively high concentration of metal species, and it is well known that some metal species drastically deteriorates conversion efficiency [7-9]. Iron, copper and nickel have been given special attention due to the impact on solar efficiency and diffusivity in silicon matrix under thermal process. The distribution of iron, copper and nickel in multicrystalline silicon has been studied using synchrotron based X-ray technique at ALS in U.S. [10-14], BESSY-II in Germany [15-17], SPring-8 in Japan [18, 19]. The metals distribute as atomically dissolved states, nanometers silicide particles, and micrometers inclusions including metal oxide [10, 13] Nickel and copper mainly segregates at grain boundaries (GBs) due to high diffusivity, which induces recombination activity at GBs [11, 13]. The recombination activities of intentionally iron-incorporated GBs have been studied by electron beam induced current (EBIC) method [20-23]. On the other hand, recombination activity of GBs without intentional metal contamination has not been adequately studied. In this study, relation between nickel distribution, recombination activity, and crystallographic structure of GBs before and after thermal process using synchrotron-based x-ray fluorescence microscopy (µ-XRF), electron beam induced current (EBIC) method, and electron back scatter diffraction pattern (EBSD) method.

2. Experimental
Ga doped mc-Si ingot was grown by unidirectional casting method using off-specification of electronics grade polycrystalline silicon as feedstock. The grown ingot was cylindrical-shaped with a diameter and a height of approximately 100 mm, and was sliced into 300-µm-thick substrates. To compare effects of annealing temperatures, three adjacent substrates were used in this study. The set of substrates were selected from the upper part of the ingot with a fraction solidified ~0.85, where concentration of impurities is relatively high due to segregation phenomena. The concentrations of impurities were measured using the inductively coupled plasma mass spectrometer (ICP-MS) and atomic absorption spectrometry (AAS) methods. The average iron, copper and nickel concentrations were 3.5 x 10¹⁷, 1.0 x 10¹⁴, and 3.3 x 10¹⁴ atoms/cm³, respectively. The first substrate was left unprocessed, and the second and third substrates were subjected to thermal treatment at 650 °C for 120 min and 1000 °C for 90 min with an N₂ ambient, respectively. The crystallographic orientation was analyzed by scanning electron microscope equipped with a TSL EBSD pattern collection system. The distributions of transition metals and their chemical states in the substrates were studied using synchrotron-based measurements at the beam line 37XU in SPring-8. The distribution was analyzed by the µ-XRF mapping with an energy of 10 keV, a beam size of 0.7 x 1.5 µm and a sampling pitch of 5 µm. The recombination activity was characterized by the EBIC measurements on the aluminum Schottky carrier separation.

3. Results and Discussion
XRF mappings for nickel signal and EBIC images of the unprocessed, 650 °C annealed, and 1000 °C annealed samples were shown in Fig. 1 (a) and (b), respectively. The position of observed region is identical to each sample in
In summary, nickel dramatically redistributes by thermal process at as low temperature as 650 °C. Nickel does not redistribute at most CSL GBs and some specific random GBs. At some GBs, nickel segregates after one annealing but not the other annealing. There are GBs indicating EBIC contrast without nickel, so recombination activity is not necessarily related to nickel distribution. The different metal capture and release activity of random GBs is to be studied.

4. Conclusion

Effects of annealing at low and high temperatures on nickel distribution and GBs recombination activity was studied by synchrotron-based x-ray analysis and EBIC. Nickel differently redistributes by different thermal conditions. Recombination activity is not necessarily related to nickel distribution.

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